

Notice of References Cited	Application/Control No. 10/554,416		Applicant(s)/Patent Under Reexamination DABROWSKI ET AL.	
	Examiner Benny Lee		Art Unit 2817	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,030,713	04-2006	Ralph, Loren	333/111
*	B	US-6,759,923	07-2004	Scott et al.	333/116
*	C	US-5,446,425	08-1995	Banba, Seiichi	333/116
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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